

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: *Ramiro N. Castellanos et al.*

Examiner: Sheela C. Chawan

Serial No.: 10/035,592

Group Art Unit: 2625

Filed: October 23, 2001

Docket No.: A126.169.101

Due Date: April 14, 2005 (with one-month extension)

Title: **SYSTEM AND METHOD FOR INSPECTION USING OFF-ANGLE
LIGHTING**

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Non-Final Office Action mailed December 14, 2004. Please amend the above-identified patent application as follows:

04/08/2005 MAHMED1 00000038 500471 10035592

01 FC:2201 100.00 DA
02 FC:2202 25.00 DA